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APPLICANTS Ryoji Hoshi, Fukushima, JAPAN; Susumu Sonokawa, Fukushima, JAPAN;				
** CONTINUING DATA ***** This application is a 371 of PCT/JP03/08671 07/08/2003				
** FOREIGN APPLICATIONS ***** JAPAN 2002-204703 07/12/2002				
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged _____ Examiner's Signature _____ Initials _____		STATE OR COUNTRY JAPAN	SHEETS DRAWING 6	TOTAL CLAIMS 29
				INDEPENDENT CLAIMS 3
ADDRESS 25944				
TITLE Silicon wafer for epitaxial growth, epitaxial wafer, and its manufacturing method				
FILING FEE RECEIVED 1350	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	